

Application No.: 10/702,048

Docket No. FIS920060072US1

(RAJ-013)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:  
FUKIAGE et al.

Confirmation Number: 7394

Application No.: 10/702,048

Group Art Unit: 1792

Filed: November 6, 2003

Examiner: Tadayyon Eslami, Tabassom

Title: Method for Depositing Materials on a Substrate

AMENDMENT AFTER FINAL REJECTION

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

In response to the Final Office Action dated October 1, 2008, the due date for the response being January 1, 2009, please amend the above-identified application as follows: